

INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>	Docket Number (Optional) SHM-01901	Application Number To Be Assigned
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Applicant Junichi FUJIKATA	Group Art Unit To Be Assigned
Filing Date December 28, 2001	

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA					
	AB					
	AC					
	AD					
	AE					
	AF					
	AG					
	AH					
	AI					
	AJ					
	AK					

31000 U.S. PTO
 10/033669
 12/28/01

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
<i>phys</i>	AL 9-83039	3-28-97	JP			<i>abstract</i>	
"	AM 2000-163716	6-16-00	JP			"	
"	AN 2000-215415	8-4-00	JP			"	
	AO						
	AP						
	AQ						

OTHER DOCUMENTS

(Including author, Title, Date, Pertinent Pages, Etc.)

<i>phys</i>	AR	"Symposium on Spin Tunneling and Injection Phenomena" Journal of Applied Physics, Vol 79, pp. 4724-4729 (1996)
"	AS	"Symposium on Magnetoelectric Devices for Information Storage", Journal of Applied Physics, Vol. 81, pp.3741-3746 (1997)
"	AT	"Exchange-biased ferromagnetic tunnel junctions via reactive evaporation of nickel oxide films", Applied Physics Letters, Vol. 72, pp. 605-607 (1998)
"	AU	"Spin-Valve-Like Properties and Annealing Effect in Ferromagnetic Tunnel Junctions", IEEE Transactions of Magnetics, Vol. 33, pp. 3553-3555 (1997)

EXAMINER <i>[Signature]</i>	DATE CONSIDERED 7/6/03
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.